

PATENT

**IN THE UNITED STATES PATENT AND TRADEMARK OFFICE**

**Present Application:**

Applicant : Guy F. Hudson  
Attorney Docket No. : 500155.05  
Filed : Concurrently herewith  
Title : METHODS FOR USING BI-MODAL ABRASIVE SLURRIES FOR  
MECHANICAL AND CHEMICAL-MECHANICAL PLANARIZATION OF  
MICROELECTRONIC-DEVICE SUBSTRATE ASSEMBLIES

**Prior Application:**

Examiner : Lan Vinh  
Art Unit : 1765  
Serial No. : 10/155,203

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**PRELIMINARY AMENDMENT**

Mail Stop Patent Application  
Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

Sir:

Please amend the above-identified application as follows:

Amendments to the Specification begin on page 2 of this paper.

Amendments to the Claims are reflected in the listing of claims which begins on page 3 of this paper.

Remarks begin on page 10 of this paper.